

41 FIGs. 22(a)-22(c)' are plan and sectional views of the main part of an ink jet recording head according to a twelfth embodiment of the invention;

Page 26, please delete the sixth full paragraph, and replace it with the following new paragraph:

42 In the embodiment, the conductive film 65 is formed of one layer, but the invention is not limited to it. For example, as shown in Fig. 24(c)', the conductive film 65 may be formed of two layers 65a, 65b. In this case, preferably each of the two layers has a compressive stress, but the invention is not limited to it; at least the upper layer 65a may have a compressive stress.

IN THE CLAIMS:

Please enter the following amended claims:

Sub B1
43 1. (Amended) An ink jet recording head of the type having (1) a flow passage formation substrate in which a pressure generation chamber and a nozzle opening are formed, (2) a diaphragm provided on said flow passage formation substrate, said diaphragm defining an interior wall of said pressure generation chamber, (3) a piezoelectric element provided on said diaphragm, said piezoelectric element having at least a lower electrode, a piezoelectric layer, and an upper electrode, said ink jet recording head comprising:

a compression film having (1) a compressive stress and (2) at least a part in a thickness direction removed in an area opposed to said pressure generation chamber, thereby forming a removal part.